

Form 1449 (Modified)

Information Disclosure
Statement By Applicant

(Use Several Sheets if Necessary)

Atty Docket No.
NOVLP090/NVLS-2888Application No.:
10/733,858

Applicant:

Zhu et al.

Filing Date

December 10, 2003

Group

2812

U.S. Patent Documents

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub-class	Filing Date
<i>DKS</i>	A1	5,705,419	01/1998	Perry et al.			
	A2	5,342,801	08/1994	Perry et al.			
	A3	5,385,857	01/1995	Solo de Zaldivar			
	A4	4,361,461	11/1982	Chang			
	A5	6,027,663	02/2000	Martin et al.			
	A6	5,270,264	12/1993	Andideh et al.			
	A7	5,227,191	7/1993	Nagashima			
	A8	5,246,885	9/1993	Braren et al.			

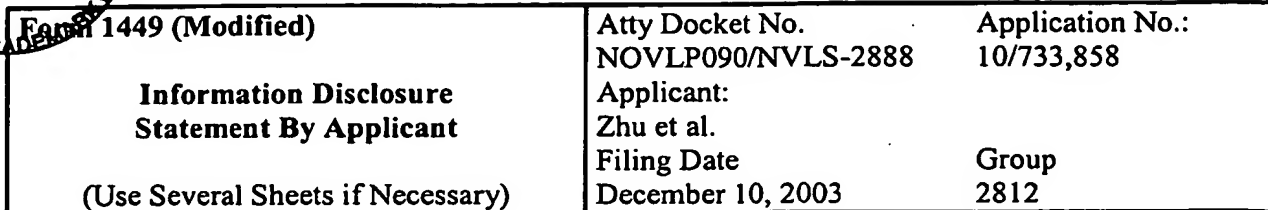
Foreign Patent or Published Foreign Patent Application

Examiner Initial	No.	Document No.	Publication Date	Country or Patent Office	Class	Sub-class	Translation Yes	Translation No

Other Documents

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
<i>DKS</i>	C1	Papasouliotis et al., "Method of Chemical Modification of Structure Topography", U.S. Patent Application No. 10/004,386, filed December 3, 2001.
Examiner		Date Considered
<i>[Signature]</i>		<i>4/15/05</i>

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.



Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub-class	Filing Date
ZKS	A9	5,282,925	2/1994	Jeng et al.			
	A10	5,494,854	2/1996	Jain			
	A11	5,532,516	7/1996	Pasch et al.			
	A12	5,621,241	4/1997	Jain			
	A13	5,622,894	4/1997	Jang et al.			
	A14	5,636,320	6/1997	Yu et al.			
	A15	5,641,545	6/1997	Sandhu			
	A15	5,702,982	12/1997	Lee et al.			
	A17	5,789,818	8/1998	Havermann			
	A18	5,851,344	12/1998	Xu et al.			
	A19	5,858,876	1/1999	Chew			
	A20	5,869,902	2/1999	Lee et al.			
	A21	5,872,058	2/1999	Van Cleemput et al.			

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Pg. 2 of 3



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<i>BKS</i>	A22	5,897,370	4/1999	Joshi et al.			
	A23	5,910,020	6/1999	Yamada			
	A24	5,911,133	6/1999	Yao et al.			
	A25	5,913,140	6/1999	Roche et al.			
	A26	5,920,792	7/1999	Lin			
	A27	5,937,323	8/1999	Qrezyk et al.			
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	A32	5,972,192	10/1999	Dubin et al.			
	A33	6,077,451	6/2000	Takenaka et al.			
	A34	6,331,494	12/2001	Olson et al.			
	A35	6,395,150	5/2002	Van Cleemput et al.			

Foreign Patent or Published Foreign Patent Application

Examiner Initial	No.	Document No.	Publication Date	Country or Patent Office	Class	Sub-class	Translation	
							Yes	No

Other Documents

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
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B/S	A1	6,030,881	02/29/00	Papasouliotis			
	A2	6,265,269	07/24/01	Chen et al.			
	A3	6,277,764	08/21/01	Shin et al.			
	A4	6,335,261	01/01/02	Natzle, et al.			
	A5	6,479,396	11/12/02	Xu et al.			
	A6	6,569,777	05/27/03	Hsu et al.			
	A7	2001-0019903	09/06/01	Shufflebotham et al.			
	A8	2004-0058549	03/25/04	Cai, Yuqi et al.			
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	A10	6,531,377	03/11/03	Knorr et al.			
	A11	5,516,729	05/14/96	Dawson et al.			
	A12	6,566,229	05/20/03	Hong et al.			
	A13	6,500,728	12/31/02	Wang			
	A14	6,479,361	11/12/02	Park			
	A15	6,642,105	11/04/03	Kim et al.			
	A16	2003-0087506	05/08/03	Kirchhoff			
	A17	6,596,654	06/22/03	Bayman et al.			

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	C1	
Examiner	Date Considered	
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